

“Atomic layer deposition-based tuning of the pore size in mesoporous thin films studied by in situ grazing incidence small angle X-ray scattering”. Dendooven J, Devloo-Casier K, Ide M, Grandfield, Kurttepel, Ludwig KF, Bals S, Van der Voort P, Detavernier C, *Nanoscale* **6**, 14991 (2014). <http://doi.org/10.1039/c4nr05049e>